

2. (recited) The system of claim 1, wherein the functional blocks of the SMPW comprise structural arrays.

3. (recited) The system of claim 1, wherein the SMPW is pre-fabricated up to a contact layer so that a user can customize and program different blocks of the SMPW to the user's requirements.

4. (recited) The system of claim 1, wherein the IC design flow has a cycle time of approximately 1-3 months.

5. (recited) The system of claim 1, wherein the functional blocks are chosen from a group comprising: metal programmable PLLs; master/slave DLLs; metal programmable I/O elements; sea of gates; memory; and high speed serial links.

6. (recited) A component architecture for use in a streamlined integrated circuit (IC) design process comprising:

a plurality of sub-blocks targeted to specific applications, wherein the architecture is pre-fabricated up to a contact layer in order to allow a user to customize and program the sub-blocks to the user's requirements through metallization.

7. (recited) The component architecture of claim 6, wherein the sub-blocks are structural arrays.

8. (recited) The component architecture of claim 6, wherein the sub-blocks are chosen from a group comprising: metal programmable PLLs; master/slave DLLs; metal programmable I/O elements; sea of gates; memory; and high speed serial links

9. (recited) A method for designing an integrated circuit (IC) comprising:  
providing a plurality of structural multi-project wafers (SMPWs), each SMPW comprising a plurality of pre-manufactured and pre-validated functional blocks;  
if one of the plurality of SMPWs meets an IC designer's requirements, proceeding to a streamlined design flow and production;  
if one of the plurality of SMPWs is usable as an intermediate step, extracting usable SMPW component(s) for use in a normal COT flow; and  
if one of the plurality of SMPWs does not meet a user's requirement and is not usable as an intermediate step, extracting any usable IP from the plurality of SMPWs for use in a normal COT flow.

10. (recited) The method of claim 9, wherein the streamlined design flow has a cycle time of 1-3 months and wherein the normal COT design flow has a cycle time of 12-24 months.

11. (recited) A method for providing integrated circuit design assistance comprising:  
maintaining an inventory of structural multi-project wafers (SMPWs), each SMPW comprising a plurality of pre-manufactured and pre-validated functional blocks.

12. (recited) A method as claimed in claim 11, wherein the functional blocks are metal programmable to a user's specific requirements.

13. (recited) A method as claimed in claim 11, further comprising:  
determining whether one of the inventory of SMPWs can meet all of a user's IC design requirements or can serve an intermediate step in a user's IC design process, such as market/concept validation or IP validation.

14. (recited) A method as claimed in claim 13, further comprising:  
determining whether any IP useful to a user's requirement is contained within the inventory of SMPWs.

15. (recited) A method as claimed in claim 11, and further comprising:  
reducing manufacturing costs to users by sharing the SMPWs among multiple users.
16. (recited) A method as claimed in claim 11, and further comprising:  
maintaining a pool of validated IP that is embodied in the inventory of SMPWs.
17. (amended) A method as claimed in claim 16, and further comprising:  
transferring an IP component from the pool of validated IP from [to] programmable logic  
for use in COT flow.
18. (recited) A method as claimed in claim 11, and further comprising:  
facilitating migration to a COT flow with the inventory of SMPWs.
19. (recited) A method as claimed in claim 11, and further comprising:  
providing multiple packaging and assembly options for SMPW users.
20. (recited) A method as claimed in claim 19, wherein the packaging and assembly  
options are chosen from a group comprising: wire bond, flip chip, BGA, plastics and ceramics.

**REMARKS**

Applicants respectfully request that the foregoing amendments be entered before  
examination of the above-captioned application.